

章嵩 简历

武汉理工大学，材料复合新技术国家重点实验室，副研究员

教育经历：

2007/9 - 2010/6，武汉理工大学，材料加工工程，博士，导师：张联盟

2004/9 - 2007/7，武汉理工大学，材料学，硕士，导师：张联盟

2000/9 - 2004/6，武汉理工大学，材料科学，学士

工作经历：

2012/12 - 至今，武汉理工大学，材料复合新技术国家重点实验室，副研究员

2011/1 - 2012/10，（日本）东北大学，金属材料研究所，助理研究员

2010/10 - 2012/10，华中科技大学，光学与电子信息学院，讲师

【主持科研项目】

- 1、 国家科技部国际合作专项项目，2014DFA53090、大尺寸碳化硅的激光化学气相沉积技术及应用合作研发、2014/12-2017/11、284万元、在研、主持。
- 2、 国际企业委托项目(揖斐电株式会社)，卤化物化学气相沉积法制备Ti-Si-C复合材料厚膜成型技术、2015/01-2015/12、4700万日元（约256万元）、在研、主持。
- 3、 国家自然科学基金项目（青年基金），51102101、基于脉冲激光沉积富硼B-C 薄膜的关键技术研究、2012/01-2014/12、24万元、已结题、主持。
- 4、 湖北省自然科学基金面上项目，2014CFB870、3C-SiC晶体缺陷表征与控制研究、2014/01-2015/12、3万元、在研、主持。
- 5、 事业委托项目，制备高致密度、细晶粒B-C陶瓷、2013/06-2013/12、2.2万元、已结题、主持。

【参加科研项目】

- 1、 国家自然科学基金面上项目，51372188、高温超导氧化物薄膜的激光化学气相沉积技术、2014/01-2017/12、80万元、在研、参加。
- 2、 湖北省创新群体项目，2016CFA006，功能薄膜材料的结构与性能调控、2016/09-2019/09、30万元、在研、参加。

【人才计划项目】

- 1、湖北省楚天学者（楚天学子，2013年，材料加工工程）。
- 2、武汉理工大学 青年拔尖人才（第二批次，2016年）

近5年主要研究成果

【期刊论文】

- 1、 Hong Cheng, Rong Tu, **Song Zhang***, Mingxu Han, Takashi Goto, Lianmeng Zhang, Preparation of highly oriented β -SiC bulks by halide laser chemical vapor deposition, *Journal of the European Ceramic Society*, 37(2) 509-515, 2017
- 2、 Rong Tu, Dinghen Zheng, Hong Cheng, Mingwei, **Song Zhang***, Mingxu Han, Takashi Goto, Lianmeng Zhang, Effect of $\text{CH}_4/\text{SiCl}_4$ ratio on the composition and microstructure of $\langle 110 \rangle$ -oriented β -SiC bulks by halide CVD, *Journal of the European Ceramic Society*, 37(4) 1217-1223, 2017
- 3、 Peipei Zhu, Qingfang Xu, Ruyi Chen, **Song Zhang***, Meijun Yang, Rong Tu, Lianmeng Zhang, Takashi Goto, Jiasheng Yan, Shusen Li, Structural study of β -SiC(001) films on Si(001) by laser chemical vapor deposition, *Journal of the American Ceramic Society*, Proofed, 2017
- 4、 Rong Tu, Dinghen Zheng, Mingxu Han, **Song Zhang***, Zhiying Hu, Takashi Goto, Lianmeng Zhang, Ultra-Fast Fabrication of $\langle 110 \rangle$ -Oriented β -SiC Wafers by Halide CVD, *Journal of the American Ceramic Society*, 99(1) 84-88, 2016
- 5、 **Song Zhang**, Qingfang Xu, Zhiying Hu, Peipei Zhu, Rong Tu*, Lianmeng Zhang, Mingxu Han, Takashi Goto, Jiasheng Yan, Sijun Luo, Ultra-fast epitaxial growth of β -SiC films on $\alpha(4\text{H})$ -SiC using hexamethyldisilane (HMDS) at low temperature, *Ceramics International*, 42(3) 4632-4635, 2016
- 6、 **Song Zhang**, Qingfang Xu, Qingyun Sun, Peipei Zhu, Rong Tu*, Zhiying Hu, Mingxu Han, Takashi Goto, Lianmeng Zhang, Jiasheng Yan, Shusen Li, Effect of Pressure on Microstructure of $\langle 111 \rangle$ -Oriented β -SiC Films: Research Via Electron Backscatter Diffraction, *Journal of the American Ceramic Society*, 98(12) 3713-3718, 2015
- 7、 **Song Zhang**, Qingfang Xu, Rong Tu, Takashi Goto, Lianmeng Zhang, Growth Mechanism and Defects of $\langle 111 \rangle$ -Oriented β -SiC Films Deposited by Laser Chemical Vapor Deposition, *Journal of the American Ceramic Society*, 98(1) 214-222, 2015
- 8、 Rong Tu, Qingyun Sun, **Song Zhang***, Mingxu Han, Qizhong Li, Hedenori

- Hirayama, Lianmeng Zhang, Takashi Goto, Oxidation Behavior of ZrB₂-SiC Composites at Low Pressures, *Journal of the American Ceramic Society*, 98(1) 214-222, 2015
- 9、 **Song Zhang**, Qingfang Xu, Rong Tu*, Takashi Goto, Lianmeng Zhang, High-speed preparation of <111>- and <110>-oriented β-SiC films by laser chemical vapor deposition, *Journal of the American Ceramic Society*, 97(3) 952-958, 2014
- 10、 Rong Tu, Peipei Zhu, **Song Zhang***, Peng Xu, Lianmeng Zhang, Hiroshi Hanekawa, Takashi Goto, Comparison of CVD-deposited Ni and Dry-blended Ni Powder as Sintering Aids for TiN Powder, *Journal of the European Ceramic Society*, 34(8) 1955-1961, 2014
- 11、 **Song Zhang**, Zhiqiang He, Xiaoli Ji, Wenzhong Lu, Chuanbin Wang, Qiang Shen, Lianmeng Zhang, Understanding the deposition mechanism of pulsed laser deposited B-C films using dual-targets, *Journal of Applied Physics*, 115(15) 154906, 2014
- 12、 Qizhong Li, **Song Zhang***, Chuanbin Wang, Qiang Shen, Wenzhong Lu, Lianmeng Zhang, Structural Evolution of B-C Thin Films Deposited from SPSed-Target and Dual-Target, *Journal of the American Ceramic Society*, 97(5) 1367-1370, 2014
- 13、 Chuanbin Wang, Xiaoshuang Luo, **Song Zhang***, Qiang Shen, Lianmeng Zhang, Effects of Nitrogen Gas Ratio on Magnetron Sputtering Deposited Boron Nitride Films, *Vacuum*, 103 (3) 68-71, 2014
- 14、 Xiaoli Ji, Shijiang Wu, **Song Zhang***, Xiujian Zhao, Study on the Reaction Mechanism of Potassium Titanate Fibers, *Integrated Ferroelectrics*, 153(1) 156-163, 2014
- 15、 Xiaoli Ji, Shijiang Wu, **Song Zhang***, Xiujian Zhao, Preparation of layered potassium titanate whiskers with large length-diameter ratio by KDC method, *Journal of Wuhan University of Technology-Mater. Sci. Ed.*, 153(1) 156-163, 2014
- 16、 Xiaoli Ji, Chengcheng Zhai, **Song Zhang***, Preparation and Study of 0.7(Mg_{0.8}Zn_{0.2})TiO₃·0.3{Ba₄Nd_{28/3}Ti₁₈O₅₄·zBi₂O₃} Microwave Dielectric Ceramics, *Advanced Materials Research*, 924(1) 115-122, 2014

- 17、 Xiaoli Ji, Fang Yi, **Song Zhang***, Chengcheng Zhai, Pengfei Hu, Effects of ZnO Addition and Sintering Temperature on Dielectric Properties of MgTiO₃ Ceramic, *Key Engineering Materials*, 616(1) 145-152, 2014
- 18、 Xiaoli Ji, Pengfei Hu, **Song Zhang***, Chengcheng Zhai, Fang Yi, Preparation and Study of $(1-m)(\text{Mg}_{0.8}\text{Zn}_{0.2})\text{TiO}_3 \cdot m\{\text{Ba}_4\text{Nd}_{28/3}\text{Ti}_{18}\text{O}_{54} \cdot 0.18\text{Bi}_2\text{O}_3\}$ Microwave Dielectric Ceramics, *Key Engineering Materials*, 616(1) 166-173, 2014
- 19、 Mingxu Han, Wei Zhou, Dingheng Zheng, Rong Tu, **Song Zhang**, Takashi Goto, Effects of C/Si Ratio on the Structure of β -SiC Film by Halide CVD, *Key Engineering Materials*, 616(1) 227-231, 2014
- 20、 Mingxu Han, Wei Zhou, Dingheng Zheng, Rong Tu, **Song Zhang**, Takashi Goto, High-Speed Deposition of SiC Thick Film by Halide Precursor, *Key Engineering Materials*, 616(1) 37-42, 2014
- 21、 **Song Zhang***, Wenzhong Lu, Chuanbin Wang, Qiang Shen, Lianmeng Zhang, Stoichiometric controlling of boron carbide thin films by using boron-carbon dual-targets, *Applied Physics Letters*, 101(14)1602-1-4, 2012
- 22、 **Song Zhang**, Rong Tu*, Takashi Goto. High-speed epitaxial growth of β -SiC film on Si(111) single crystal by laser chemical vapor deposition, *Journal of the American Ceramic Society*, 95(9)2782-2784, 2012
- 23、 **Song Zhang***, Wenzhong Lu, Chuanbin Wang, Qiang Shen, Lianmeng Zhang, Investigation of planar defects in pulsed electric current sintered B₁₃C₂ boron carbide ceramic, *Ceramics International*, 38(1)817-819, 2012
- 24、 **Song Zhang***, Wenzhong Lu, Chuanbin Wang, Qiang Shen, Lianmeng Zhang, Synthesis and characterization of B₁₃C₂ boron carbide ceramic by pulsed electric current sintering, *Ceramics International*, 38(2)895-900, 2012
- 25、 **Song Zhang***, Wenzhong Lu, Chuanbin Wang, Qiang Shen, Lianmeng Zhang, Stoichiometric controlling of pulsed laser deposited boron-carbon thin films, *Physica B*, 407(13)2382-2384, 2012
- 26、 Xiaoli Ji, Shijiang Wu, **Song Zhang***, Xiujiang Zhao, Study on the reaction mechanism of potassium titanate fibers, *Integrated Ferroelectrics*, accepted.
- 27、 Xiaoli Ji, Shijiang Wu, **Song Zhang***, Xiujiang Zhao, Preparation of layered

potassium titanate whiskers with large length-diameter ratio by KDC method, *Journal of Wuhan University of Technology-Materials Science Edition*, accepted.

- 28、 Sijun Luo*, Chuanbin Wang, **Song Zhang**, Rong Tu, Shulong Liu, Xinfeng Tang, Qiang Shen, Fei Chen, and Lianmeng Zhang, Epitaxial integration of (100) $\text{Bi}_4\text{Ti}_3\text{O}_{12}$ with (0001) ZnO through long-range lattice matching, *Applied Physics Express*, 5(8)5801-5803, 2012
- 29、 Sijun Luo*, Chuanbin Wang, **Song Zhang**, Rong Tu, Qiang Shen, Fei Chen, and Lianmeng Zhang, Preparation and characterization of transparent $\text{Bi}_{3.6}\text{Ho}_{0.4}\text{Ti}_3\text{O}_{12}/\text{ZnO}:\text{Al}$ ferroelectric-semiconductor heterostructure by pulsed laser deposition, *Materials Letters*, 79(2) 173-176, 2012

【申请专利】

- 1、 **章嵩**、徐青芳、涂溶、(日)後藤 孝 (Takashi GOTO)、张联盟, 一种立方碳化硅薄膜的制备方法, 2014, 中国, 201410317559.7
- 2、 **章嵩**、贺志强、涂溶、张联盟、王传彬、沈强, 一种组分可控的碳化硼的制备方法, 2014, 中国, 201410712152.4
- 3、 **章嵩**、贺志强、涂溶、张联盟、王传彬、沈强, 用于预测多元拼合靶材制备的薄膜成分的预测方法, 2014, 中国, 201410708998.0
- 4、涂溶、朱佩佩、**章嵩**、(日)後藤 孝 (Takashi GOTO)、张联盟, 碳化硅膜的制备方法, 2014, 中国, 201410162587.6
- 5、涂溶、朱佩佩、**章嵩**、(日)後藤 孝 (Takashi GOTO)、张联盟, 一种TiN-Ni复合陶瓷的制备方法, 2014, 中国, 201410301100.8
- 6、涂溶、孙清云、**章嵩**、张联盟, 快速制备 3C-SiC外延膜方法, 2014, 中国, 201410423183.8
- 7、**章嵩**、王传彬、沈强、张联盟、涂溶, 脉冲激光沉积装置, 2013, 中国, 201310619627.0